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Date : September 17, 2004
TO : Director, Office of Patent Publication
FROM : Office of the Deputy Commissioner
for Patent Examination Policy
SUBJECT : Withdrawal from Issue of

Applicant(s) : Hideomi Suzawa, et al.
Application No. : 09/852,672
Filed : May 11, 2001

The above-identified application has been assigned Patent No. 6,797,546 and an issue date of September 28, 2004.

It is hereby directed that this application be withdrawn from issue at the request of the applicant.

Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of September 28, 2004:

"All reference to Patent No. 6,797,546 to HIDEOMI SUZAWA, ET AL. of JAPAN for SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF appearing in the Official Gazette of September 28, 2004, should be deleted since no patent was granted."

Sherry D. Brinkley
Petitions Examiner
Office of Petitions
Office of the Deputy Commissioner
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